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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Seiji FUJITSUKA et al.

Application No.: 09/772,907

Filed: January 31, 2001

Docket No.: 108483

For: SCANNING EXPOSURE METHOD AND SYSTEM

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language reference JP A 8-166475 is discussed in the present specification.
- ☒ 3. English-language Abstracts of the non-English language references JP A 8-166475 and JP A 11-125912 are attached hereto.
- ☒ 4. U.S. Patent No. 5,528,118 corresponds to JP A 8-166475.

- ☒ 5. U.S. Patent Nos. 5,729,331 and 5,874,820 correspond to JP A 7-57986 and JP A 8-330224, which were filed in a previous Information Disclosure Statement on January 31, 2001.

Respectfully submitted,



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Date: May 8, 2001

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